

Confirmation no. 3423

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DE BOER	Examiner:	Lund, J.
Serial No.:	10/537,363	Group Art Unit:	1792
Filed:	June 2, 2005	Docket No.:	US020527US
Title:	SYSTEM AND METHOD FOR SUPPRESSION OF WAFER TEMPERATURE DRIFT IN COLD-WALL CVD SYSTEMS		

---

MAIL STOP RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No. <b>65913</b>
------------------------------

1. This is a request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.
2. Attached please find:
  - a. ☒ An Amendment with Request for Continued Examination, submitted herewith to advance the above-referenced patent application under a final rejection dated November 19, 2008.
3. Fees:
  - a. ☒ Please charge Deposit Account Number 50-0996 (NXPS.441PA) the below RCE filing fee, with authorization to charge/credit said deposit account any additional required claims fees/overages to complete this filing.
    1. ☒ The RCE filing fee **\$810.00.**

*Please direct all correspondence to:*

Corporate Patent Counsel  
NXP Intellectual Property & Standards  
1109 McKay Drive; Mail Stop S41-SJ  
San Jose, CA 95131

By: 

Name: Robert J. Crawford  
Reg. No.: 32,122  
(NXPS.441PA)

Customer No. 65913